S/N 10/789,042

**PATENT** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Kie Y. Ahn et al.

Examiner: Matthew C. Landau

Serial No.:

10/789,042

Group Art Unit: 2815

Filed:

February 27, 2004

Docket: 1303.050US2

Title:

LAALO<sub>3</sub> FILMS

## COMMUNICATION CONCERNING RELATED APPLICATION(S)

## **MS** Amendment

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Applicants would like to bring to the Examiner's attention the following related application(s) in the aboveidentified patent application:

<u>Serial/Patent No.</u> 10/926812 7081421	Filing Date/Issue Date August 26, 2004	Attorney Docket 1303.121US1	<u>Title</u> LANTHANIDE OXIDE DIELECTRIC LAYER
10/930167	August 31, 2004	1303.122US1	ATOMIC LAYER DEPOSITED LANTHANUM ALUMINUM OXIDE DIELECTRIC LAYER
11/117125	April 28, 2005	1303.139US1	ATOMIC LAYER DEPOSITION OF A RUTHENIUM LAYER TO A LANTHANIDE OXIDE DIELECTRIC LAYER

Continuations and divisionals may be later filed on the cases listed above, or cited to the Examiner in any previous Communication Concerning Related Applications. Applicants request that the Examiner review all continuations and divisionals of the above-listed or previously-cited patent applications before allowing the claims of the present patent application.

Respectfully submitted,

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<u>CERTIFICATE UNDER 37 CFR 1.8:</u> The undersigned hereby certifies that this correspondence is being filed using the USPTO's electronic filing system EFS-Web, and is addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 15 day of <u>December</u>, 2007.

JUDY DENT

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